



Robert J. Small and Xiaowei Shang

Assignee:

EKC Technology, Inc.

Title:

Chemical-Mechanical Planarization Using Ozone

Serial No.:

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INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR § 1.97(b)

Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, the documents listed on the accompanying form PTO-1449 are called to the attention of the Examiner for the above patent application. Copies of these documents are enclosed.

Citation of these documents shall not be construed as:

- an admission that the documents are necessarily prior art with respect to the 1. instant invention;
 - a representation that a search has been made; or 2.
- an admission that the information listed herein is, or is considered to be, 3. material to patentability as defined in $\S 1.56(b)$.

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Respectfully submitted, aliver de fach

K. Alison de Runtz Attorney of Record

Reg. No. 37,119

HREE EMBARCADERO

LAW OFFICES OF SKJERVEN MORRILL MacPHERSON LLP

HREE EMBARC ADERO CENTER 28" FLOOR FRANCISCO, CA 94111 (415) 217-6000 FAX (415) 434 0646

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